

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Woon-Yong PARK, *et al.*

Application No.: To be assigned

Filed: Herewith

For: **PHOTOLITHOGRAPHY METHOD
FOR THIN FILM (AS AMENDED)**

Art Unit: To be assigned

Examiner: To be assigned

Atty. Docket: 6192.0091.D2

Preliminary Amendment

Commissioner for Patents
Alexandria, VA 22313

Sir:

Please amend the above-identified patent application as follows.

Amendments

In the Title:

Please amend the title to read: -- **PHOTOLITHOGRAPHY METHOD FOR THIN FILM** --.

In the Specification:

At the beginning of the specification, please enter the following paragraph.

-- **CROSS REFERENCE**